

Notice of References Cited

Application/Control No.

09/934,334

Applicant(s)/Patent Under
Reexamination
BERGER ET AL.

Examiner

Donghee Kang

Art Unit

2811

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Ulf Gennser et al., "Resonant tunneling of holes through silicon barriers", J.Vac.Sci.Technol.b 8 (2), 1990, pp 210.			
	V	A.N.Larsen et al., "Diffusion of Sb in relaxed SiGe", Appl.Phys.Lett. 68 (19), 1996, pp 2684.			
	W				
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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